



PATENT  
Docket No. 506212001100

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Michihiko YANAGISAWA *et al.*

Serial No.: 10/623,740

Filing Date: July 22, 2003

For: LOCAL DRY ETCHING METHOD

Examiner: Shamim Ahmed

Group Art Unit: 1765

Conf. No.: 5259

**AMENDMENT UNDER 37 CFR 1.116**

M/S AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Action mailed October 20, 2005, please amend this application as follows:

**The listing of claims begins on page 2.**

**The Remarks begin on page 4.**

DO NOT  
enter  
SA  
1/25/06